Docket No.: 4425-320

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of

Chien-Hsin LAI et al.

Confirmation No. 3535

U.S. Patent Application No. 10/659,258

Group Art Unit: 1763

Filed: September 11, 2003

Examiner: Karla A Moore

For:

PLASMA APPARATUS AND METHOD CAPABLE OF ADAPTIVE IMPEDANCE

MATCHING

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Notice of Non-Compliant Amendment mailed January 13, 2006, please amend the above-identified application as follows: